



Docket No. 740819-548

**RESPONSE UNDER 37 CFR 1.116 – EXPEDITED  
PROCEDURE – EXAMINING GROUP 2800**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Mitsuru TANABE

Serial No.: 09/838,214

Filed: April 20, 2001

For: MICROSTRIP LINE, METHOD FOR  
FABRICATING THE SAME,  
INDUCTOR ELEMENT, AND RF  
SEMICONDUCTOR DEVICE

)

) Group Art Unit: 2817

) Examiner: Benny T. LEE

) Confirmation No.: 9367

) Date: September 18, 2003

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SEP 29 2003  
TC 2800 MAIL ROOM

**CERTIFICATE OF MAILING**

[37 CFR 1.8(a)]

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on September 22, 2003.

Signature: Sharon L. Tabor  
Name: Sharon L. Tabor

**AMENDMENT AFTER FINAL**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed June 18, 2003, please amend the above identified application as follows.

09/26/2003 MBIZUHES 00000040 09830214  
01 FC:1201 84.00 GP

NVA276853.2